

Notice of References Cited	Application/Control No. 10/694,295	Applicant(s)/Patent Under Reexamination MAKI ET AL.	
	Examiner DANH C. LE	Art Unit 2683	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-2005/0165951	07-2005	Wang et al.	709/237
*	C	US-2003/0003913	01-2003	Chen et al.	455/436
*	D	US-2002/0094837	07-2002	Hamabe et al.	455/522
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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